

Sami Sneek

List of Publications by Year in descending order

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Version: 2024-02-01

11
papers

244
citations

1307594

7
h-index

1474206

9
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11
all docs

11
docs citations

11
times ranked

342
citing authors

#	ARTICLE	IF	CITATIONS
1	20.8% industrial PERC solar cell: ALD Al ₂ O ₃ rear surface passivation, efficiency loss mechanisms analysis and roadmap to 24%. Solar Energy Materials and Solar Cells, 2017, 161, 14-30.	6.2	118
2	Hospitalizations Due to Adverse Drug Events in the Elderly—A Retrospective Register Study. Frontiers in Pharmacology, 2016, 7, 358.	3.5	32
3	Effective passivation of p+ and n+ emitters using SiO ₂ /Al ₂ O ₃ /SiN _x stacks: Surface passivation mechanisms and application to industrial p-PERT bifacial Si solar cells. Solar Energy Materials and Solar Cells, 2018, 186, 356-364.	6.2	31
4	Medication competency of nurses according to theoretical and drug calculation online exams: A descriptive correlational study. Nurse Education Today, 2016, 36, 195-201.	3.3	21
5	Nurses' self-assessments of adherence to guidelines on safe medication preparation and administration in long-term elderly care. Scandinavian Journal of Caring Sciences, 2020, 34, 108-117.	2.1	18
6	Data of ALD Al ₂ O ₃ rear surface passivation, Al ₂ O ₃ PERC cell performance, and cell efficiency loss mechanisms of Al ₂ O ₃ PERC cell. Data in Brief, 2017, 11, 19-26.	1.0	10
7	The Risks and Outcomes Resulting From Medication Errors Reported in the Finnish Tertiary Care Units. Frontiers in Pharmacology, 2019, 10, 1571.	3.5	10
8	Data of the recombination loss mechanisms analysis on Al ₂ O ₃ PERC cell using PC1D and PC2D simulations. Data in Brief, 2017, 11, 27-31.	1.0	2
9	Batch Atomic Layer Deposition of Aluminum Nitride for RF-MEMS and GAN Power-Devices. , 2019, , .		1
10	Detecting Patient Safety Errors by Characterizing Incidents Reported by Medical Imaging Staff. Frontiers in Public Health, 2022, 10, 846604.	2.7	1
11	Rotary Spatial Plasma Enhanced Atomic Layer Deposition — An enabling manufacturing technology for Åµm-thick ALD films. , 2017, , .		0